

Sheet 1 of 1

Form PTO-1449 (Modified)  <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION (USE SEVERAL SHEETS IF NECESSARY)</b>				Atty. Docket No. <b>2238/5</b>		Application No. <b>10/750,760</b>	
				Applicant: <b>Medina et al</b>		Group Art Unit: <b>2883</b>	
				Filing Date: <b>05 JAN 2004</b>			
<b>U.S. PATENT DOCUMENTS</b>							
	EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
AA	DLD	6,459,845	OCT 02	Lee et al			
AB	DLD	5,845,023	Dec 98	Lee			
AC							
AD							
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION
							YES      NO
AE							
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
AF	DLD	H Toshiyoshi et al; "A5 Volt Operated Mems Variable Optical Attenuator" 12 <sup>th</sup> International Conference on Solid State Sensors, Actuators and Microsystems, Boston, June 8-12 2003					
AG	DLD	Ford et al; "Dynamic Spectral Power Equalization using Micro-Optics-Mechanics", IEEE Photon. Tech.lett. vol. 10, No. 10 (1998), pp. 1440-1449					
AH	DLD	Aksyuk; "Low insertion loss packaged and fibre connectorised mems reflective optical switch" Electronics Letters, vol 34, no.14 (1998) pp 1413					
AI	DLD	Legtenberg et al; "Comb-drive actuators for large displacements" Micromech. Microeng; 6 pp 320-329 1996					
AJ	DLD	Lee et al; "Design and characteristics of a micromachined variable optical attenuator with a silicon optical wedge" Optics Communications 221 (2003) 323-330					
EXAMINER <b>Dark 2. [Signature]</b>				DATE CONSIDERED <b>12/14/2005</b>			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformation and not considered. Include copy of this form with next communication to applicant.							